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U.S. UTILITY Patent Application

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PATENT NUMBER and
ISSUE DATE

APPL NUM 10014131	FILING DATE 12/13/2001	CLASS 445	SUBCLASS 2879	GAU 2879	EXAMINER Ramsey
**APPLICANTS: Onishi Toshikazu; Banba Yoshikazu; Nishimura Michiyo; Takeda Toshihiko; Yamamoto Katsuke; Maruyama Tomoko;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A DIV OF 09/848,360 05/04/2001 WHICH IS A DIV OF 09/248,102 02/11/1999 PAT 6,267,636					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 10-029538 02/12/1998					
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed		<input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no		35.C13314 D2	
Verified and Acknowledged Examiners's initials					
TITLE : Method for manufacturing electron emission element, electron source, and image forming apparatus					

U.S. DEPT. OF COMMERCE/PAT. & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims Print Claim for O.G.	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner Application Examiner	
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